



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Confirmation No: 9025

Hideki MUNAKATA

Attorney Docket No: 107242-00021

Serial Number: 09/926,173

Group Art Unit: 1762

Filed: September 18, 2001

Examiner: Wesley D. Markham

For: WAFER STORAGE CASE, PROCESS FOR PREVENTING DUST
GENERATION THEREOF AND WAFER STORING METHOD

RESPONSE UNDER 37 C.F.R. § 1.121

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

Date: April 27, 2004

Sir:

This paper is in reply to the Office Action dated January 7, 2004, the period to respond being extended one (1) month from April 7, 2004 to May 7, 2004 by the enclosed Petition for Extension of Time.

IN THE DRAWINGS:

Enclosed herein are replacement sheets of Figures 9-12 and 14, which have been amended to include a --Prior Art-- legend because only that which is old is illustrated.